



Atty. Dkt. No. 023312-0109

***IN THE UNITED STATES PATENT AND TRADEMARK OFFICE***

Applicant: Takashi NAGASE et. al.

Title: METHOD OF MANUFACTURING NANO-GAP ELECTRODE

Appl. No.: 10/662,886

Filing Date: 09/16/2003

Examiner: Ahmed, Shamim

Art Unit: 1765

**AMENDMENT AND REPLY UNDER 37 CFR 1.111**

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

This communication is responsive to the Non-Final Office Action dated June 10, 2005, concerning the above-referenced patent application.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this document.

**Remarks/Arguments** begin on page 6 of this document.

Please amend the application as follows: